

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: H. INAGAWA et al  
Serial No. 09/604,903  
Filed: June 28, 2000

Group Art Unit: 2823  
Examiner: F. Toledo  
For: SEMICONDUCTOR DEVICE AND METHOD FOR  
FABRICATING THE SAME

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

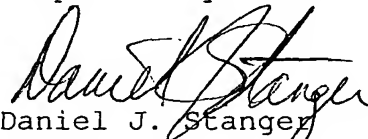
September 9, 2003

Sir:

In accordance with the duty of disclosure, the Applicants inform the Examiner of the documents cited during prosecution of the parent application, USSN 09/604,903.

The Applicants request the Examiner to initial and return a copy of the attached PTO-1449 form as an indication that the references have been considered.

Respectfully submitted,



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Date: September 9, 2003

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. H-924-02	SERIAL NO.	
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>				APPLICANT H. INAGAWA et al		
				FILING DATE 09/09/03		GROUP 2823
<b>U.S. PATENT DOCUMENTS</b>						
* EXAMINER INITIAL	DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE <i>(If Appropriate)</i>
AA	5,237,187	08/1993	Suwanai et al			
AB	5,612,557	03/1997	Kondo et al			
AC	5,717,254	02/1998	Hashimoto et al			
AD	5,621,232	04/1997	Ohno			
AE	5,734,175	03/1998	Taniguchi			
AF	5,972,768	10/1999	Nagayasu et al			
AG	4,666,556	05/1987	Fulton et al			
AH	6,406,998	06/2002	Prall et al			
AI	4,835,585	05/1989	Panousis			
AJ	6,008,114	12/1999	Li			
AK	6,107,196	08/2000	Rolfson			
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATIO YES      NO
AL	2000-196075	07/2000	Japan			<input type="checkbox"/> <input type="checkbox"/>
AM						<input type="checkbox"/> <input type="checkbox"/>
AN						<input type="checkbox"/> <input type="checkbox"/>
AO						<input type="checkbox"/> <input type="checkbox"/>
AP						<input type="checkbox"/> <input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>						
	AR					
	AS					
	AT					
EXAMINER			DATE CONSIDERED			
<small>* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form next communication to applicant.</small>						

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<b>U.S. PATENT DOCUMENTS</b>							
* EXAMINER INITIAL		DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE <i>(If Appropriate)</i>
	AA	6,472,317	10/2002	Wang et al			
	AB	6,482,735	11/2002	Givens et al			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATIO YES NO
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	AM						<input type="checkbox"/> <input type="checkbox"/>
	AN						<input type="checkbox"/> <input type="checkbox"/>
	AO						<input type="checkbox"/> <input type="checkbox"/>
	AP						<input type="checkbox"/> <input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
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